

<b>Notice of References Cited</b>	Application/Control No. 10/642,330	Applicant(s)/Patent Under Reexamination SHIN, CHEN-HWA	
	Examiner Tai Duong	Art Unit 2871	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0141284	07-2004	Chen et al.	361/681
	B	US-2004/0160733	08-2004	Hsu, Chen-Hua	361/681
	C	US-6,850,407	02-2005	Tanimoto et al.	361/681
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
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**NON-PATENT DOCUMENTS**

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